# CABLINE<sup>®</sup>-SS

Small Gauge Coaxial Connector

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# CABLINE<sup>®</sup>-SS : Specificatio

Standard small gauge coaxial connector with various pin counts

Segment : Notebook PC / Tablet PC / DVC / DSC



CABLINE<sup>®</sup>-SS









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# CABLINE<sup>®</sup>-SS : Features

- Pass through small hinge hole 1.
- 2. Higher reliable connection

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## 1. Pass through small hinge hole

## Small vertical mating type connector for small hinge assembly after cable termination



## Side View



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# 2. Higher reliable connection

W-point contact (High reliability technology)

Cylindrical shape with two contact points

- 1. Resist flux and powder
- 2. Lower contact resistance







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## Summary

- Pass through small hinge hole  $\checkmark$
- Higher reliable connection by I-PEX's unique W-Point contact structure  $\checkmark$

![](_page_5_Picture_6.jpeg)

![](_page_5_Picture_7.jpeg)

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![](_page_5_Picture_9.jpeg)

# Appendix-1. CABLINE<sup>®</sup>-SS : Specifications

Rated current	0.1AA
Rated voltage	50V (p
Operating Temperature	-40°C
Dielectric Withstanding Voltage	*Pleas
Insulation Resistance	*Pleas
Contact Resistance	Groun
Durability cycles	30 cyc
Mating Height (MAX.)	1.65 m
Mating Depth	3.00 m
Mating Width	21.8 m
Applicable Wire	Micro- Discre

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### C/DC

- per contact)
- to +85°C
- se contact our sales for details
- se contact our sales for details
- d Shell : 50m ohm / max.
- les
- nm (1.85 mm)
- nm
- nm (40 pin)
- -coax AWG#42, 40, 36 ete AWG#36,34
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![](_page_6_Picture_17.jpeg)

![](_page_6_Picture_18.jpeg)

![](_page_6_Picture_19.jpeg)

# Appendix-2. W-point contact confirmation of effect (1)

Attachment test of Flux After dipping Plug into Flux in 1 minutes and dry it for 24 hours, we match with Rece and measure contact resistance.

Flux application : Tamura Corporation MH-820V

![](_page_7_Picture_3.jpeg)

![](_page_7_Figure_4.jpeg)

### Test Result

W-point CT did not find any conduction defect.

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![](_page_7_Figure_9.jpeg)

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![](_page_7_Picture_11.jpeg)

![](_page_7_Picture_12.jpeg)

![](_page_7_Picture_13.jpeg)

## Appendix-3. W-point contact confirmation of effect (2)

## LCP Powder Dust Test

After spreading powder dust as picture on the Rece, we measure contact resistance of 1, 2, 5, 30 times with matching with Plug.

![](_page_8_Picture_3.jpeg)

### Test Result

LCP Powder Dust effect of W-point contact is much less than common product.

![](_page_8_Picture_6.jpeg)

![](_page_8_Figure_9.jpeg)

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![](_page_8_Picture_11.jpeg)

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![](_page_8_Picture_12.jpeg)

![](_page_9_Picture_0.jpeg)

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![](_page_9_Picture_2.jpeg)